

Notice of References Cited	Application/Control No. 10/509,496	Applicant(s)/Patent Under Reexamination NARUSAWA ET AL.	
	Examiner Minh H. Chau	Art Unit 2854	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0111042 A1	05-2005	Ogiwara, Satoshi	358/001.18
*	C	US-2005/0174600 A1	08-2005	Kitahara et al.	358/001.15
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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